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The Patent Office

Cardiff Road Newport Gwent NP9 1RH

1. Your reference

P22384/TCO/GMU

Patent application number (The Patent Office will fill in this part)

26 MAR 1999

9906886.8

Full name, address and postcode of the or of each applicant (underline all surnames)

Bede Scientific Instruments Limited Bowburn South Industrial Estate Bowburn Durham DH6 5AD

Patents ADP number (if you know it)

If the applicant is a corporate body, give the country/state of its incorporation

701327300)

United Kingdom

Title of the invention

"Method and Apparatus for Prolonging the Life of an X-ray Target"

Name of your agent (if you bave one)

"Address for service" in the United Kingdom to which all correspondence should be sent (including the postcode)

Murgitroyd & Company

373 Scotland Street. GLASGOW G5 8QA

Patents ADP number (if you know it)

1198013

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Country

Priority application number (if you know it)

Date of filing (day / month / year)

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Number of earlier application

Date of filing (day / month / year)

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a) any applicant named in part 3 is not an inventor, or

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Patents Form 1/77

Method and Apparatus for Prolonging the Life of an 2 X-Ray Target 3 This invention relates to an X-ray generator, and in 4 particular to apparatus for prolonging the life of an 5 X-ray target used within an X-ray generator. 6 7 Known X-ray generators comprise an electron gun, an X-8 ray target and an X-ray exit window. 9 These generators produce X-rays by accelerating electrons from the 10 electron gun into the x-ray target. X-rays are emitted 11 from the target through the exit window. 12 generators may be in the form of sealed X-ray tubes, 13 for example microfocus tubes, which are evacuated once 14 and then sealed off, or in the form of rotating anode 15 generators, which are permanently connected to vacuum 16 pumps and are continuously evacuated during operation. 17 18 A major limitation to the longevity of X-ray generators 19 is the lifetime of the target. All targets degrade 20 21 over time due to the effects of heat and roughening caused by the electron bombardment. There are various 22 23 known methods for reducing these effects, including 24 cooling the back of the target with flowing water or rotating the target so that no one area of the target 25 26 is continuously subjected to the electron bombardment.

Methods of increasing the cooling efficiency have been 1 proposed based on using high conductivity materials 2 such as diamonds. However, these methods are not in 3 4 common usage currently. 5 6 With known X-ray generators, it can take a number of 7 minutes after switching on the machine before it has stabilised and is ready for use. As a result, many 8 generators are simply left running throughout the day, 9 so that the "warm-up" or stabilisation delay is 10 11 This means that the electrons are focussed on the target for long periods of time during each use of 12 the generator, which leads to accelerated degradation 13 of the target, even though the radiation produced by 14 the X-ray generator is used only for short periods. 15 16 In cases where the construction of the generator 17 permits, the target can be replaced. Where the 18 construction does not permit target replacement in a 19 routine procedure, then it is common practice to 20 21 discard the complete tube assembly making up the X-ray 22 generator. 23 In commercially available sealed tube and rotating 24 anode generators, there is no provision to control the 25 position of the beam on the target or to control the 26 quality, size or shape of the focal spot on the X-ray 27 target. The quality of the X-ray beam emitted can deteriorate rapidly with prolonged use due to contamination and damage to the target area under continuous electron bombardment. In the case of rotating anode generators, once performance has degraded below a useful level, replacement of the target is required. This entails cost of replacement parts as well as significant down

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time of the generator. 1 In the case of sealed tube generators t is necessary to discard the whole tube and 2 replace it with a new tube. 3

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It is an object of the present invention to provide 5 6 means to lengthen the life of a target, and thereby to lengthen the life of the X-ray generator. 7 controlling the position and brightness of the beam, 8 the apparatus according to the present invention can 9 reposition and modify the area of focus of the beam. 10 Defocussing the beam reduces the flux per unit area of 11 12 electrons on the target. Repositioning the beam enables a fresh area of the target to be exposed to 13 14 electrons. The lifespan of the target is prolonged by either of these means, and the time interval between 15 replacements of the target or of the complete tube 16

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assembly is increased.

A consequence of the approach of the present invention is that the tube is only required to run in operational condition with the target exposed to focussed electrons when the operator requires the X-ray beam to be produced.

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25 According to the present invention, there is provided an X-ray generator comprising an electron gun, electron 26 focussing means, a target and electronic control means, 27 wherein the area of the target on which the focussing 28 means causes electrons from said electron gun to 29 30 impinge comprises an X-ray source, the control means being adapted to control the electron focussing means 31 so that the X-ray source on said target may be varied 32 in size and/or shape and/or position. 33

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According to a first aspect of the invention the 35 control means includes a switching means to switch the 36

electron focussing means between a first unfocussed state in which the X-ray source has a first area and a second focussed state in which the X-ray source has a second area smaller than said first area. The second area may be a line, a spot or some other profile. The first area may be a line of greater thickness, a spot of greater diameter or some other shape.

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9 Preferably said first area has a surface area at least 10 twice, more preferably four times, most preferably ten 11 times that of said second area.

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According to a second aspect of the invention the control means includes a switching means to switch the electron focussing means between a plurality of focussed states, whereby in each state the X-ray source is in a corresponding discrete position on said target.

The X-ray source may be in the form of a line, a spot or some other profile on the target.

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21 The electron gun may comprise an evacuated tube around which the electron focussing means is mounted outside 22 23 the vacuum. Alternatively the electron gun may comprise an evacuated tube within which the electron 24 focussing means is mounted. 25 The evacuated tube may be 26 a sealed vacuum tube or may be connected to a vacuum pump which permits continuous evacuation during 27 operation of the generator. 28

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The electron focussing means may comprise an x-y
deflection system for centring the electron beam in the
tube. The electron beam focussing means may further
comprise at least one electron lens, preferably an
axially symmetric or round lens, and/or at least one
quadrupole or multipole lens for focussing the electron
beam to a line focus and for steering the electron

1 beam. 2 The electron beam lenses may be magnetic or 3 4 electrostatic. 5 Preferably the target is metal, most preferably a metal 6 selected from the group Cu, Ag, Mo, Rh, Al, Ti, Cr, Co, 7 Fe, W, Au. 8 The target surface may be orientated such that the plane of the target surface is perpendicular 9 or at an angle to the axis of the X-ray tube. 10 11 According to a third aspect of the present invention 12 there is also provided a method for extending the life 13 of a target of an X-ray generator, wherein the 14 generator comprises an electron gun, electron focussing 15 means and a target, the method comprising the steps of: 16 firing electrons at the target such that the area of 17 the target on which the focussing means causes 18 electrons from said electron gun to impinge comprises 19 20 an X-ray source, 21 controlling the electron focussing means to move between a first unfocussed state in which the X-ray 22 source has a first area and a second focussed state in 23 24 which the X-ray source has a second area smaller than said first area, the intensity of electron impingement 25 in the first state being sufficiently low to reduce 26 target degradation, the intensity of electron 27 impingement in the second state being sufficiently high 28 such that the source produces a predetermined required 29 level of brightness and source size on the target. 30 source may be a spot, a line or some other profile. 31 32 Preferably the electron beam current is substantially 33 the same in the first and second states, while the 34 intensity of the beam per unit area at the target is 35 lower in the first state than in the second state. 36

- According to a fourth aspect of the present invention 1 2 there is provided a method for extending the life of a 3 target of an X-ray generator, wherein the generator comprises an electron gun, electron focussing means and 4 a target, the method comprising the steps of: 5 6 firing electrons at the target such that the area of 7 the target on which the focussing means causes electrons from said electron gun to impinge comprises 8 9 an X-ray source. 10 controlling the electron focussing means to move between a plurality of focussed states, whereby in 11 each state the X-ray source is in a corresponding 12 discrete position on said target, such that the 13 14 intensity per unit area in each discrete position is 15 substantially constant, and such that there is no 16 overlap on the target between the discrete positions 17 corresponding to each focussed state. The source may be a spot, a line or some other profile. 18 19 The lack of overlap between the discrete positions on 20 21 the target means that a fresh area of target is used as a source each time the electron focussing means moves 22 23 to a new state. The control of the electron focussing 24 means may be manual but is preferably electronic, so that each discrete position corresponds to a pre-25 programmed control signal applied to the electron 26 27 focussing means. 28 29 An embodiment of the invention will now be described, 30 by way of example only, with reference to the 31 accompanying figures, where: 32 Fig. 1 shows a schematic longitudinal section through 33
- an X-ray generator according to the invention suitable for use with a close coupled X-ray focussing system (not shown);

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       Fig. 2 shows a schematic arrangement of an X-ray
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       generator in the focussed state;
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       Fig. 3 shows a schematic arrangement of an X-ray
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       generator in the defocussed state;
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       Fig. 4 shows a schematic arrangement of an X-ray
       generator with the target in a first focussed position;
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      Fig. 5 shows a schematic arrangement of an X-ray
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      generator with the target in a second focussed
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      position;
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      Figs. 6(a) and 6(b) shows schematically a side view and
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      plan view respectively on a sealed tube X-ray generator
16
      according to the invention; and
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      Figs. 7(a) and 7(b) shows schematically a side view and
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      front view respectively on a rotating anode X-ray
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      generator according to the invention. .
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      With reference to Fig. 1, the X-ray generator 1
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      comprises an evacuated and sealed X-ray tube 2,
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      containing an electron gun 3 and an X-ray target 4.
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      The tube 2 has an exit window 6 through which X-rays
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      are emitted from the target. Although the embodiment
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      illustrated in Fig. 1 has a window 6 in front of the
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      target 4, it is to be understood that the invention is
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      applicable to other embodiments, for example X-ray
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      generators in which the X-rays are emitted behind the
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      target 4.
                 The exit window does not form part of the
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      invention and is not further described.
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     The tube 2 is contained within a housing 13.
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     generator 1 also includes a system 7 for focussing and
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1 steering the electron beam onto the target 4. 2 3 The focussing and steering system is capable of 4 producing a well focussed beam of electrons impinging 5 on the target 4. The electron beam may be focussed 6 into a spot or a line, and the dimensions of the spot 7 and line as well as its position may be changed electronically. In typical X-ray applications a spot - 8 focus having a diameter falling in the range 1 to 100 10 μ m, generally 5 μ m or larger, may be required. Alternatively a line focus may be achieved whose width 11 12 falls in the range 0.4 mm to 1.0 mm, and length in the 13 range 5 mm to 15 mm. 14 The electron beam is produced by an electron gun 3 15 16 consisting of a Wehnelt electrode and cathode. 17 cathode may be a filament of tungsten or alloy, for example tungsten-rhenium, having either a hairpin or a 18 19 staple shape. Alternatively the cathode may be an 20 indirectly heated activated dispenser cathode, which 21 may be flat or of other geometry, for example a rod with a domed end. The dispenser cathode has the 22 23 advantage of extended lifetime and increased mechanical 24 With a flat surface the dispenser cathode has the further advantage of requiring only an 25 26 approximate degree of alignment in the Wehnelt 27 electrode. 28 29 Primary focus is achieved by an anode at a suitable distance from the electron gun. 30 31

The electron beam from the gun is centred in the X-ray tube 2 by a centring coil 14 or set of quadrupole 33 34 Alternatively it may be centred by multipole 35 Alternatively mechanical means may be used to

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centre the electron beam. 36 The centring lens or coil 14 may be omitted, where the electron gun 3 is such that it produced an electron beam which is sufficiently aligned within the tube 2.

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The electron beam is then focussed to a spot of varying diameter. Focussing down to a diameter of less than 5 $\mu\mathrm{m}$ or better may be achieved by an axial focussing lens 15 of the quadrupole, multipole or solenoid type.

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The spot focus may be changed to a line focus with a 10 stigmator lens 16, which may comprise a further set of 11 quadrupole or multipole lenses. Lines with an aspect 12 ratio of greater than 10:1 are possible. A line focus spreads the load on the target. When viewed at a suitable angle, the line appears as a spot.

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The lenses 15, 16 are preferably magnetic, but may be 17 electrostatic. All the lenses are electronically 18 controlled, enabling remote control and continuous 19 alignment and scanning of the focal spot. Change from 20 spot to line focus and change of beam diameter are also 21 controlled remotely by varying the control signals to 22 the electron focussing devices 7. 23

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25 The electronic control of the lenses enables the 26 electron beam to be defocussed and/or repositioned on 27 the target 4. As a result, the high intensity focal spot of the electron beam is not continuously being 28 29 directed at one particular area of the target 4, which means that the rate of degradation of the target will 30 be significantly slower than with known X-ray 31 32 generators. The electron beam is only focussed at high 33 intensity when the X-ray beam is required.

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The actions of defocussing and refocussing the electron 35 beam are activated either at will by the operator by 36

1 varying the power of the focussing coils, preferably by 2 an electronic switch control, or automatically by the 3 action of a shutter on the output side of the X-ray 4 beam or other external event defined by the operator.

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The target 4 is a metal, for example Cu, but it can be another material depending on the wavelength of the characteristic radiation required, for example Aq, Mo, Al, Ti, Rh, Cr, Co, Fe, W or Au. The target 4 is either perpendicular to the impinging electron beam, or may be inclined to decrease the absorption of the emitted X-rays.

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14 In an example of a preferred embodiment of the present invention, the cathode is at negative high voltage and 15 16 the electron gun 3 consists of a filament just inside 17 the aperture 11 of a Wehnelt grid which is biased 18. negatively with respect to the filament. The electrons 19 are accelerated towards the anode which is at ground 20 potential and pass through a hole in the latter and 21 then through the tube 2 towards the target 4. of beam deflection coils 14, which may be iron-cored, 22 23 are employed in two planes separated by 30 mm, mounted 24 between the anode of the electron gun 3 and the focussing lens 15 to centre the beam. 25 focussing lens 15 and the target 4 is an air-cored 26 quadrupole magnet which acts as a stigmator 16 in that 27 it turns the circular cross-section of the beam into an 28 29 elongated one. This quadrupole 16 can be rotated about 30 the tube axis so as to adjust the orientation of the 31 The beam can be moved about on the target 32 surface 4 by controlling the currents in the four coils of the quadrupole 16. 33

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35 With reference to Figs. 2 and 3 there is shown a tube 2, electron gun 3 and target 4, together with electron

focussing means 7, which are discussed in more detail In the first focussed state, as shown in Fig. 2, the electron beam 30 is focussed by the focussing means 7 so that it forms a relatively small spot 20 on the target 4, the spot source being the required size for generation of X-rays for the intended purpose. this state the X-ray generator is operational and the brightness of the emitted X-ray beam may be controlled by varying the applied power to the tube. When the generator is switched to the second unfocussed state as shown in Fig. 3, the electron beam 31 has the same power, but the focussing means does not focus the beam 31 so tightly, so that it forms a relatively larger spot source 21 on the target 4. In this state the Xray generator is in standby mode and the intensity per unit area at the target 4 is greatly reduced. consequent localised degradation of the target, which depends on local intensity per unit area, is also reduced.

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With reference to Figs. 4 and 5 there is shown a tube 2, electron gun 3 and target 4, together with electron focussing means 7, which are discussed in more detail In the first focussed state, as shown in Fig. 4, the electron beam 32 is focussed by the focussing means 7 so that it forms a relatively small spot source 22 on the target 4, the spot source being the required size for generation of X-rays for the intended purpose. In this state the X-ray generator is operational and the brightness of the emitted X-ray beam may be controlled by varying the applied power to the tube. When the generator is switched to a second focussed state, as shown in Fig. 5, the electron beam 33 has the same power, but is focussed by the focussing means to a second spot source 23 on a different part of the target The spot source 23 is the required size for

generation of X-rays for the intended purpose, and will generally be he same size as the spot source 22 in the first state. There is no overlap between the positions of spot sources 22 and 23.

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6 In practice there may be further operational states in 7 which the spot source is the same size as spot sources 8 22, 23 but in different, non-overlapping locations. 9 may be possible to fit as many as ten or more non-10 overlapping sources on a target, thus giving a ten-fold 11 increase in the life of the target. The focussing 12 means 7 may be adjusted manually to move the spot source, or the control signals required to adjust the 13 14 focussing means may be stored electronically, so that 15 the apparatus automatically steps to the next state when an operator indicates that the position of the 16 17 focus should be changed. The stepping could be automatic after a predetermined elapsed operating time 18 19 at a particular state, for example an elapsed time counter could be built into the apparatus to show a 20 21 warning signal when the predetermined operating time is 22 The operator would then be alerted to switch 23 the apparatus to the next state.

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25 Although the examples of Figs. 2 to 5 have been described with reference to spot sources, it is to be 26 27 understood that the invention is equally applicable to 28 line focus sources. Furthermore the illustrated 29 embodiments have been described with a focussing means 30 which comprises a centring lens, a focussing lens and a 31 stigmator lens. It is to be understood that the 32 functions of any of the three lenses may be combined in one or more lenses, and that the order of the 33 34 components of the focussing means may be varied.

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Figs. 6(a) and 6(b) shows schematically a side view and

plan view respectively on a conventional sealed tube X-2 ray generator. The generator comprises a sealed vacuum enclosure 30 fabricated from glass and metal, or from 3 4 ceramic and metal. Inside the enclosure 30 is an 5 electron gun 31 and a target 32. Adjacent to the target are X-ray transparent windows 33, through which 6 7 X-rays 36 are transmitted. Surrounding the vacuum enclosure between the electron gun 31 and target 32 is 8 an electrostatic or electromagnetic lens 34. 9 the target is a conventional water cooling arrangement 10 11 35. 12 The lens 34 comprises one or more sets of focussing 13 coils arranged outside the vacuum envelope of the X-ray 14 The coils forming the lens 34 may be 15 tube 30. electromagnetic or electrostatic. At least one of the 16 sets of focussing coils is used to steer the electron 17 beam from the electron gun 31 onto the target 32, and 18 may also be used to change the shape and/or size of the 19 20 A switch control (not shown) may be provided 21 which upon operation automatically provides the electrical power to the coils so as to steer the 22 electron beam to a larger focus or to a different point 23 on the target. This enables the power density loading 24 on the target 32 to be reduced when the X-rays are not 25 being used, or for new areas of the target 32 to be 26 periodically exposed when the previously exposed area 27 becomes damaged or degraded. In Fig. 6 the coils 34 28 are shown as being external to the vacuum. 29 In this way it is possible for the focussing coils 34 to be 30 31 retrofitted to an existing generator, in order to prolong the life of the generator. However the scope 32 of the invention includes the case where the coils 34 33 are built in to the generator and provided inside the 34 35 vacuum enclosure 30.

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Figs. 7(a) and 7(b) shows schematically a side view and 1 2 front view respectively on a conventional rotating anode X-ray generator. The generator comprises a 3 continuously pumped vacuum chamber 40 containing an electron gun 41 and a target 42 deposited on a cylindrical anode 43 which rotates at high speed. 6 7 Adjacent to the anode are X-ray transparent windows 44, 8 through which X-rays 46 are transmitted. Surrounding the vacuum chamber between the electron gun 41 and 9 10 target 42 is an electrostatic or electromagnetic lens 11 The anode 43 is water cooled (not shown). rotation of the anode 43 dissipates more effectively 12 13 the heat generated on the target 42, so that increased 14 power loading of the target and hence increased X-ray 15 brightness are possible.

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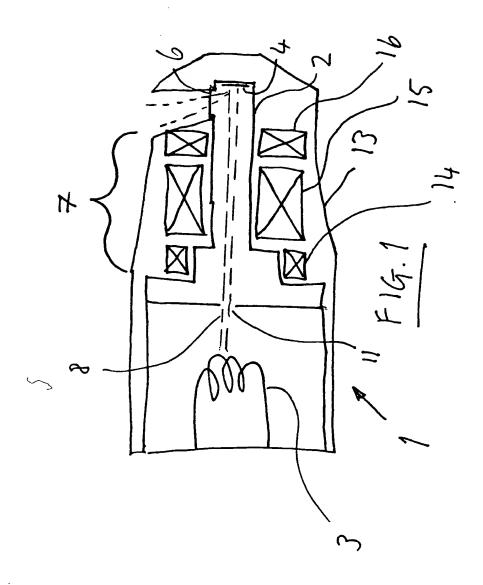
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The electrostatic or electromagnetic lens 45 comprises one or more sets of focussing coils arranged outside the vacuum chamber 40. The coils 45 serve the same purpose as the coils 34 described with reference to Fig. 6 above, and may also be retrofitted or fitted within the vacuum chamber, ie the coils may be internal or external.

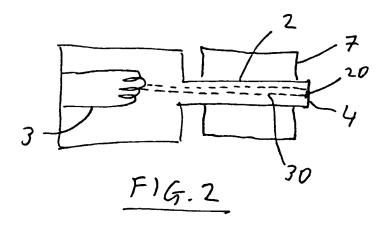
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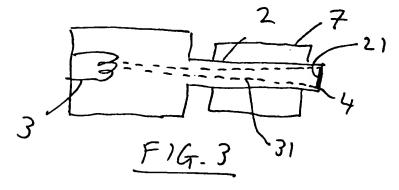
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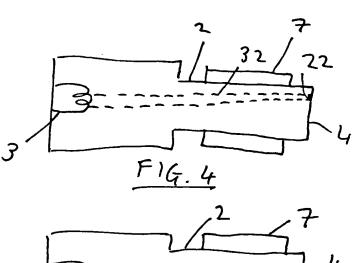
These and other modifications and improvements can be incorporated without departing from the scope of the invention.

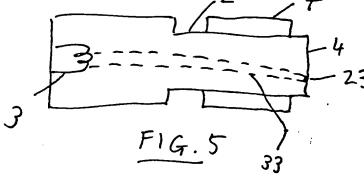


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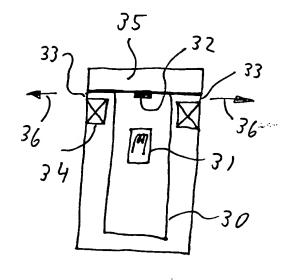
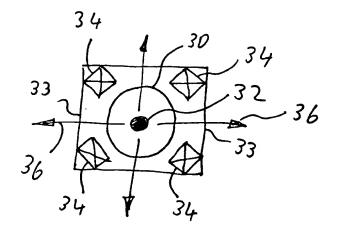
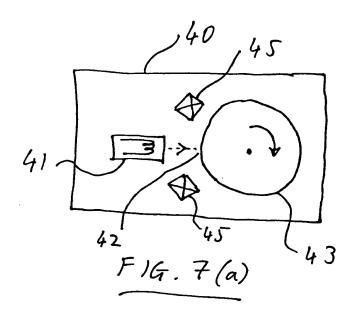
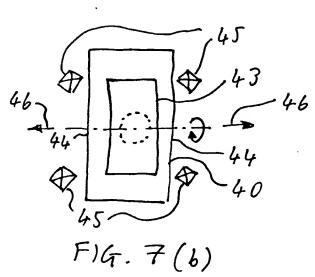


FIG. 6(a)



F1G. 6(b)





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